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APPLICANT  
Weisheng Lei and John J. Davignon

FILING DATE

GROUP  
1700

U.S. PATENT DOCUMENTS

EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
GSE	AA	5 6 1 0 7 0 7	3/11/1997	Duncan et al.	356	121	
GSE	AB	5 8 4 1 0 9 9	11/24/1998	Owen et al.	219	121.69	
GSE	AC	6 0 2 5 2 5 6	2/15/2000	Swenson et al.	438	601	
GSE	AD	6 6 7 6 8 7 8	1/13/04	O'Brien et al.	264	400	
GSE	AE	6 7 0 6 9 9 8	3/16/04	Cutler	219	121.72	
GSE	AF	Pub. No. 2002/0033558	3/21/02	Fahey et al.	264	400	
GSE	AG	Pub. No. 2002/0125227	9/12/02	Sun et al.	219	121.61	
GSE	AH	Pub. No. 2002/0185474	12/12/02	Dunsky et al.	219	121.7	
	AI						
	AJ						
	AK						

FOREIGN PATENT DOCUMENTS

EXAMINER INITIAL		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION YES NO
GSE	AL	4 0 3 4 7 4 5	7/1991	Germany	B23K26	02	X
	AM						
	AN						
	AO						
	AP						

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, etc.)

GSE	AR	What's PLD?, available at <a href="http://ap.polyu.edu.hk/pld/PLD.html">http://ap.polyu.edu.hk/pld/PLD.html</a> , dated 5/5/2003, 4 pgs.
GSE	AS	Pulsed Laser Deposition and Plasma Investigations, Dr. Geoff Martin, On the Pulse, Dec/ 00 - Feb. 00, Vol. 1, issue 4, 4 pgs., available at <a href="http://www.andor-tech.com/pulse/otpdec99.pdf">http://www.andor-tech.com/pulse/otpdec99.pdf</a> .
	AT	

EXAMINER

*Jeffrey L. Evans*

DATE CONSIDERED

08/19/2004

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